

<b>Notice of References Cited</b>			Application/Control No.	Applicant(s)/Patent Under Reexamination	
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			Examiner	Art Unit	Page 1 of 1
			Cybille Delacroix-Muirheid	1614	

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N	10-7709	01-1998	JP		
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**NON-PATENT DOCUMENTS**

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	U	HCAPLUS, DN:128:147502, Toba et al., JP 10007709, (1998), abstract only for JP 10-7709.
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	X	<i>CM</i> 12-12-05

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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